

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	TOMINAGA KOJI ET AL.)	
)	Group Art Unit: 2813
Serial No.:	10/550,805)	
)	Examiner: Luke, Daniel M.
Filed:	July 12, 2006)	
)	Confirmation No. 3990
For:	METHOD FOR FORMING AN)	
	INSULATING FILM IN A)	
	SEMICONDUCTOR DEVICE)	

VIA EFS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT FILED WITH REQUEST FOR CONTINUED EXAMINATION (RCE)

Sir:

This Amendment is respectfully submitted in response to the Final Office Action dated August 24, 2010. Applicants hereby respectfully petition for a two month extension of time. If there are any charges with respect to this Amendment or otherwise, please charge them to Deposit Account No. 06-1130 maintained by Applicants' attorneys.

Please amend the application as follows: